

Electronic Acknowledgement Receipt

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Application Number:	10697676
International Application Number:	
Confirmation Number:	8382
Title of Invention:	CHEMICAL MECHANICAL POLISHING METHOD AND APPARATUS
First Named Inventor/Applicant Name:	Joe G. Tran
Customer Number:	23494
Filer:	Yingsheng Tung/Jackie McBride
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1	Drawings	TI-37297_DRAWINGS.pdf	331380	no	2

Warnings:

Information:	
Total Files Size (in bytes):	331380
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<p>National Stage of an International Application under 35 U.S.C. 371 If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.</p>	